



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
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James S. Clarke et al. )  
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Serial No.: 10/828,885 )  
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Filed: April 20, 2004 )  
)  
For: Method of Forming Air Gaps in a )  
Dielectric Material Using a Sacrificial )  
Film and Resulting Devices )  
)  
Examiner: T. T. Nguyen )  
)  
Group Art Unit: 2813 )  
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Docket No.: P19019 )  
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Commissioner for Patents  
Mail Stop Non-Fee Amendment  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

This paper is submitted in response to a requirement for restriction.

**INTRODUCTORY COMMENTS**

The following remarks are proposed in response to the Office Action mailed October 18, 2005. Claims 1-33 are currently pending in the application and are subject to a restriction requirement.